

Electronic Acknowledgement Receipt

EFS ID:	1463015
Application Number:	10666671
International Application Number:	
Confirmation Number:	8251
Title of Invention:	Methods and apparatus of etch process control in fabrications of microstructures
First Named Inventor/Applicant Name:	Hongqin Shi
Customer Number:	23494
Filer:	Wade J. Brady III/Tina Smith
Filer Authorized By:	Wade J. Brady III
Attorney Docket Number:	P118-US
Receipt Date:	24-JAN-2007
Filing Date:	17-SEP-2003
Time Stamp:	17:19:34
Application Type:	Utility

Payment information:

Submitted with Payment	no
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File Listing:

Document Number	Document Description	File Name	File Size(Bytes)	Multi Part /.zip	Pages (if appl.)
1	Miscellaneous Incoming Letter	T62961_Small_Entity_Status.pdf	2478	no	1

Warnings:

Information:**Total Files Size (in bytes):**

2478

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New Applications Under 35 U.S.C. 111

If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

National Stage of an International Application under 35 U.S.C. 371

If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.